



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Nunan et al.

Atty. Docket: 2550/193

Serial No.: 10/791,638

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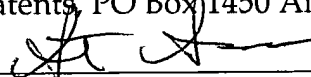
Date: March 27, 2006

Invention: SINGLE CRYSTAL SILICON SENSOR WITH ADDITIONAL LAYER AND METHOD OF PRODUCING THE SAME

Examiner: Bradley Smith

Certificate of Mailing

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, PO Box 1450 Alexandria, VA 22313-1450 on March 27, 2006.


Steven G. Saunders

AMENDMENT

Sir:

In response to the office action dated December 15, 2005, please amend the above-identified patent application as follows:

Amendments to the Claims are listed beginning on page 2 of this paper.

Remarks begin on page 6 of this paper.